

TRANSITION FROM STRONG COUPLING TO EXCITONIC LASING IN A ZNO MICROCAVITY

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The lasing operation of a ZnO planar microcavity under optical pumping is demonstrated from T=80 to 300 K. At the laser threshold, the cavity switches from the strong coupling to the weak coupling regime.

A gain-related transition, which appears while still observing polariton branches and, thus, with stable excitons, is observed below 240 K. This mechanism is different from the standard VCSEL operation, which only relies on gain in a degenerate electron hole plasma. This supports the recent interpretation of gain mechanism in ZnO nanowires in terms of exciton scattering processes.

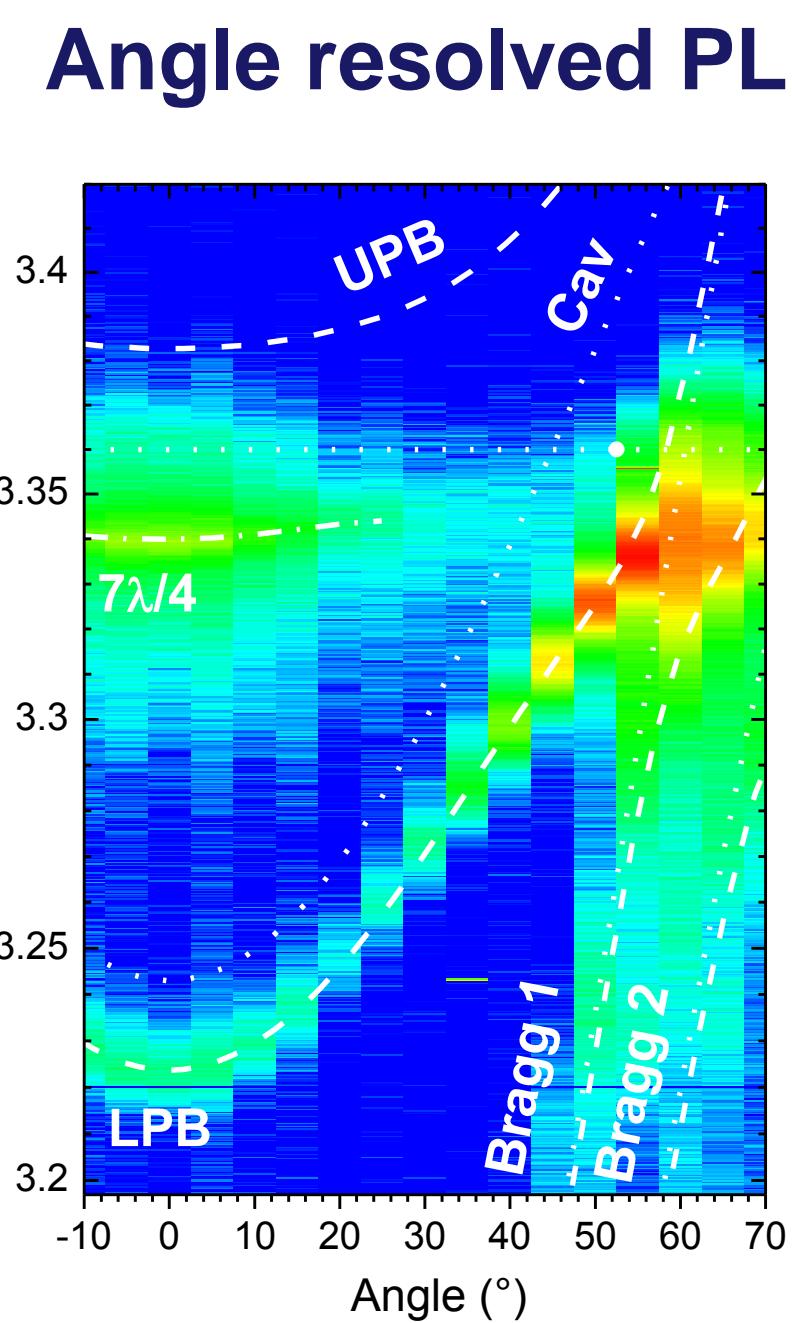
The sample



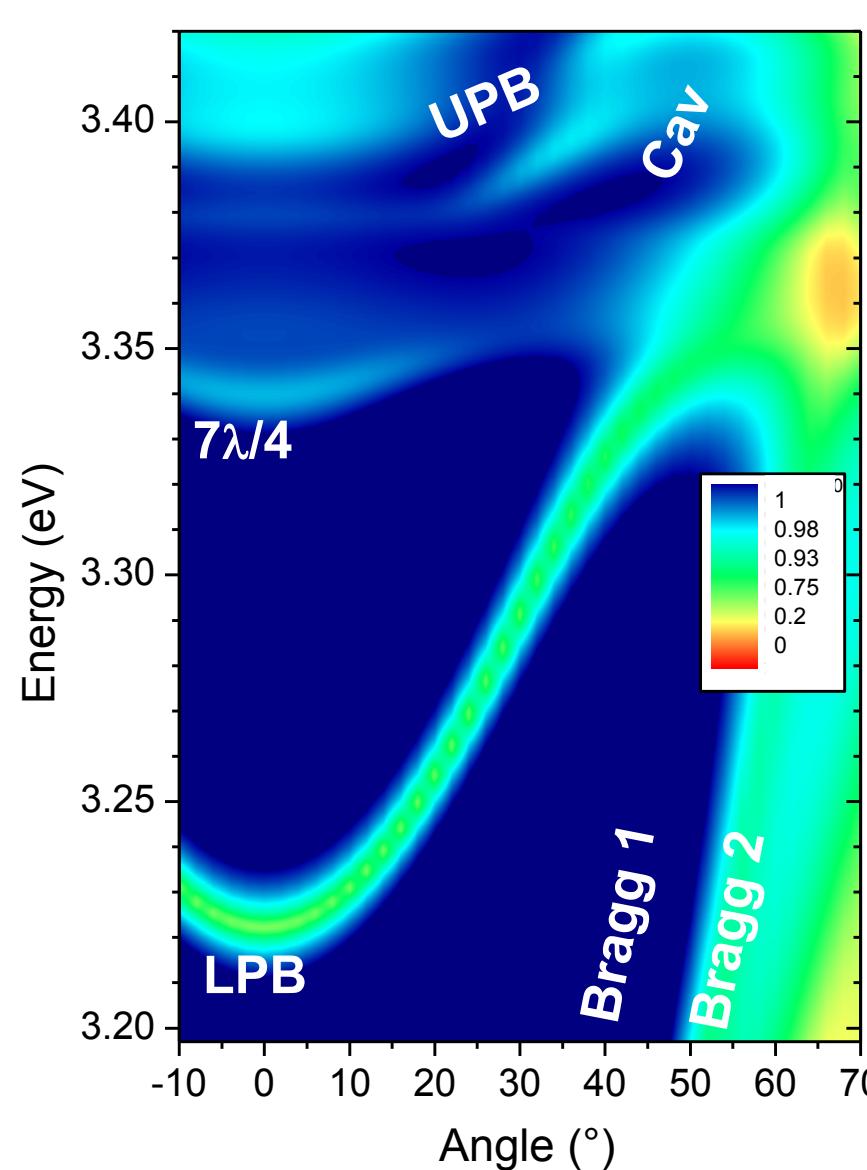
Quality factor:
Q~300 (PL)
Q~450 (μPL)

- Growth:
- SiN/SiO₂ mirror (PECVD) : S. Bouchoule (LPN)
 - ZnO active layer (MBE) : J. Zúñiga-Pérez (CRHEA)
 - Nitride mirror (MBE) : E. Frayssinet (CRHEA)

Strong exciton-photon coupling regime both at low and room temperature



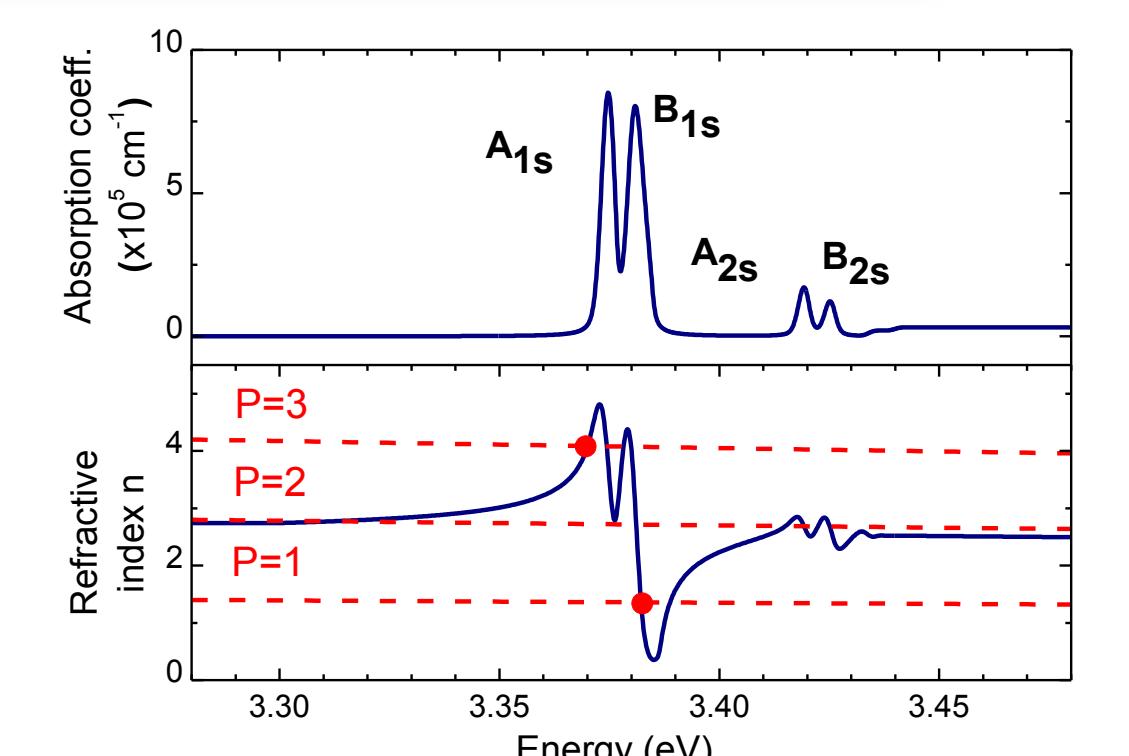
Simulated TM Reflectivity



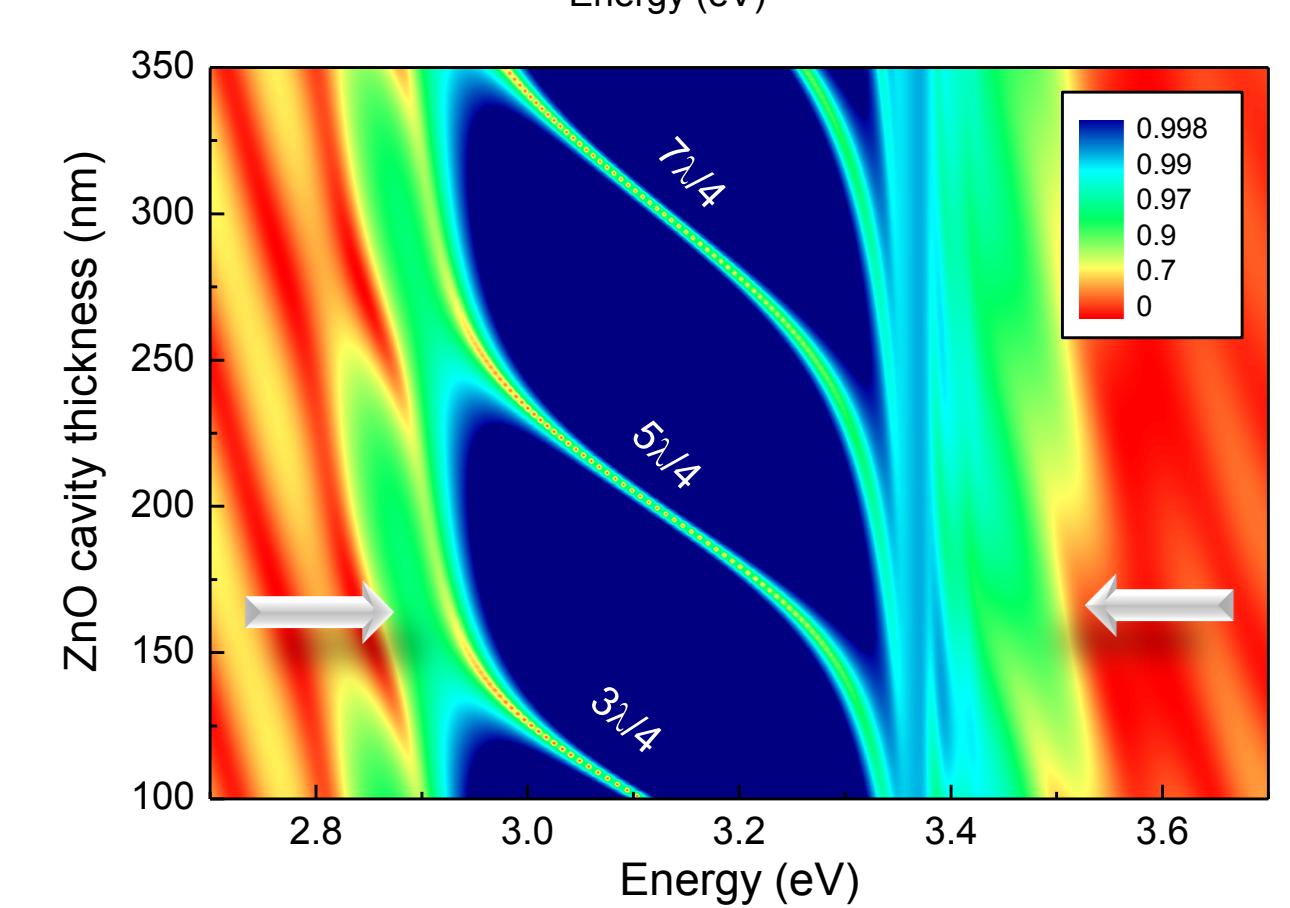
Rabi Splitting : $\Omega = 120\text{meV}$

High order mode of the cavity : $7\lambda/4$

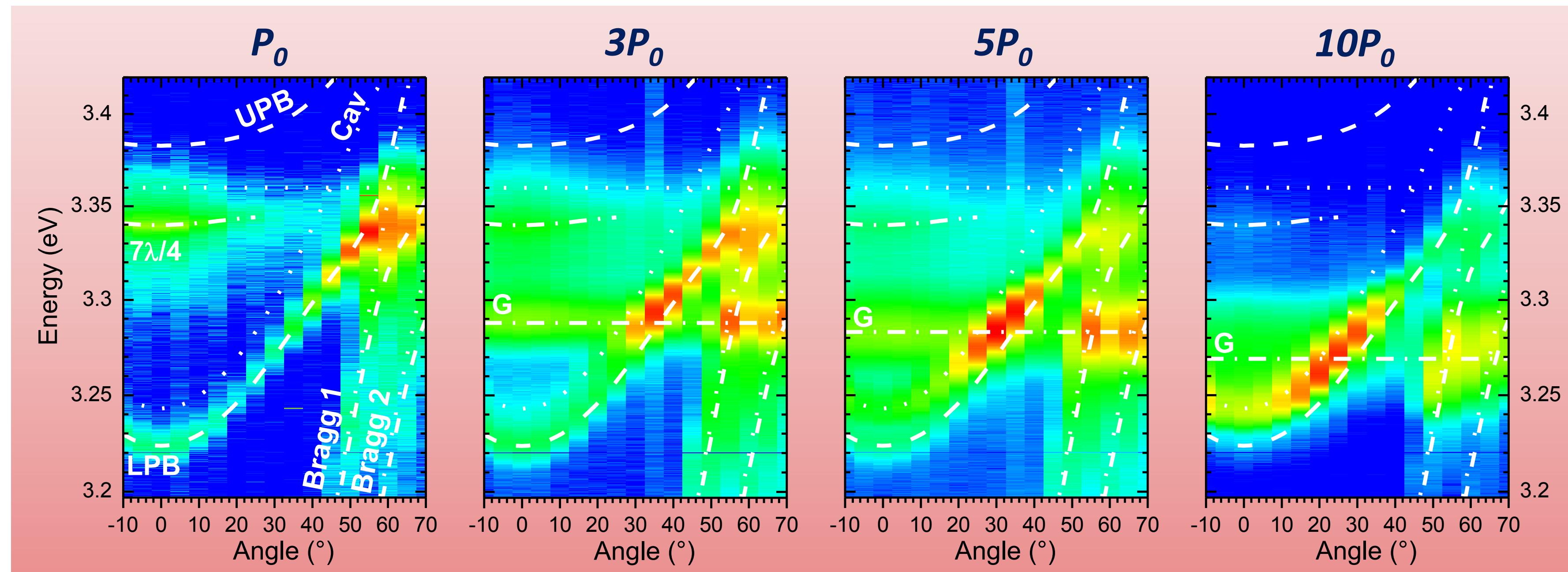
- Due to the variation of the refractive index nearby the excitonic transitions in ZnO



$$n_{ZnO}(\lambda)d_{ZnO} = \frac{P + 1/2}{2}\lambda$$



Non linear emission

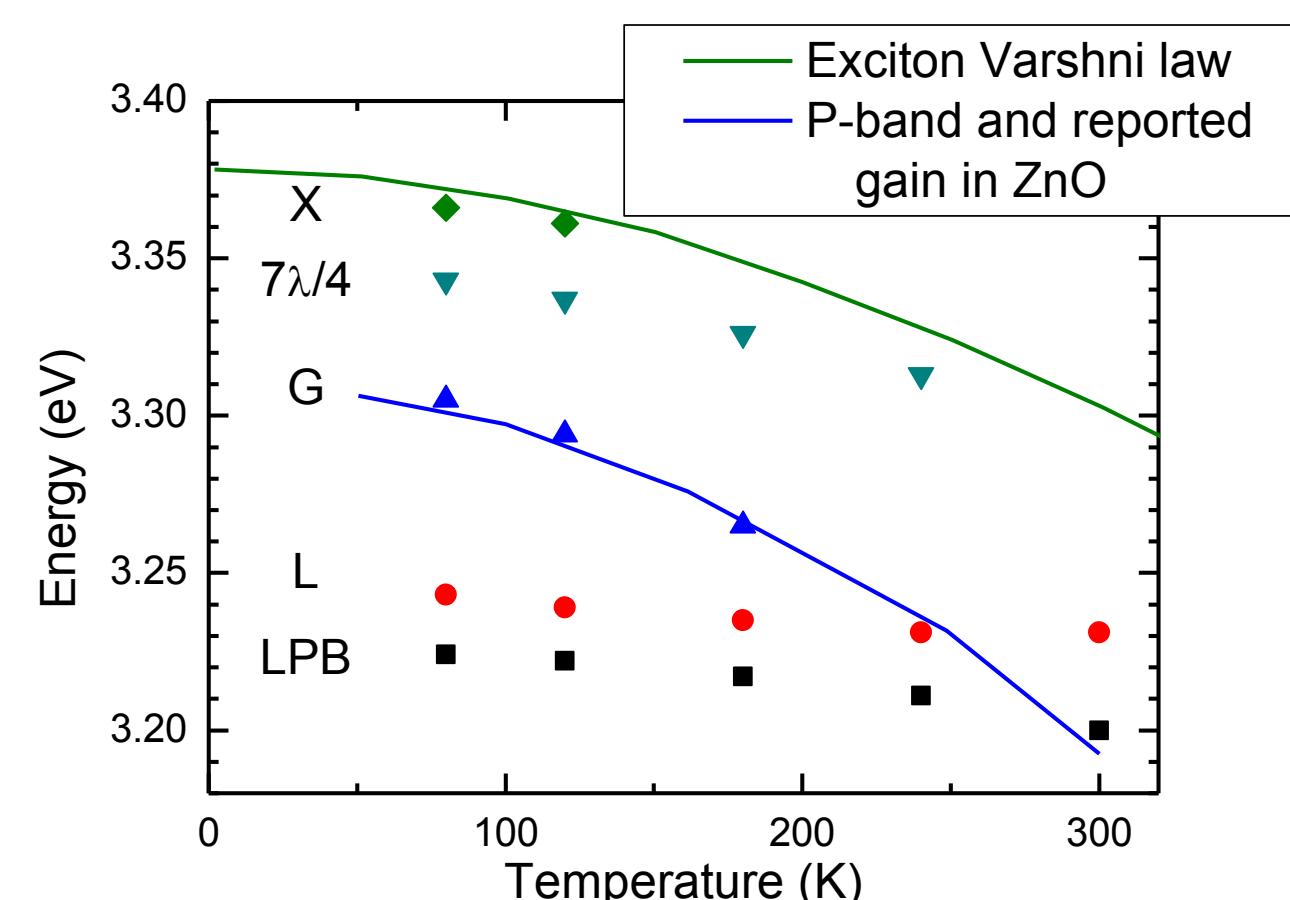


Gain transition (G)

- Starting energy does not depend on the cavity detuning and shifts to low energy as the temperature is increased
- Similar in bulk ZnO to exciton-exciton scattering processes (P-band) at low Temp. and low density, and gain in the electron-hole plasma (EHP) at higher density
- Attribute to random lasing in the plane of the cavity

Lasing transition (L)

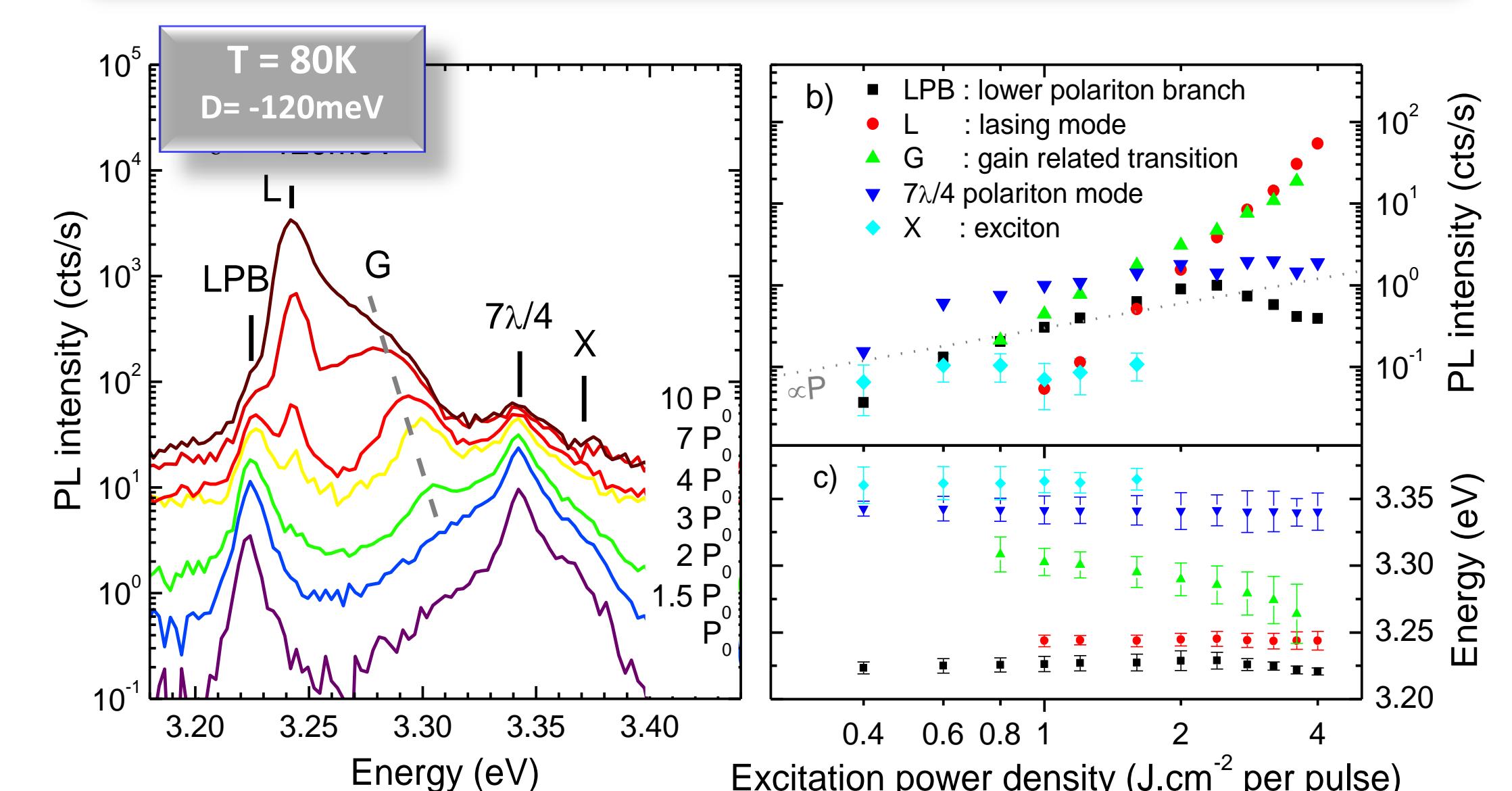
- At the energy of the uncoupled cavity mode -> the microcavity transits into the **weak coupling regime**
- Strong non-linearity of the peak intensity versus excitation power : **lasing is observed in the microcavity**



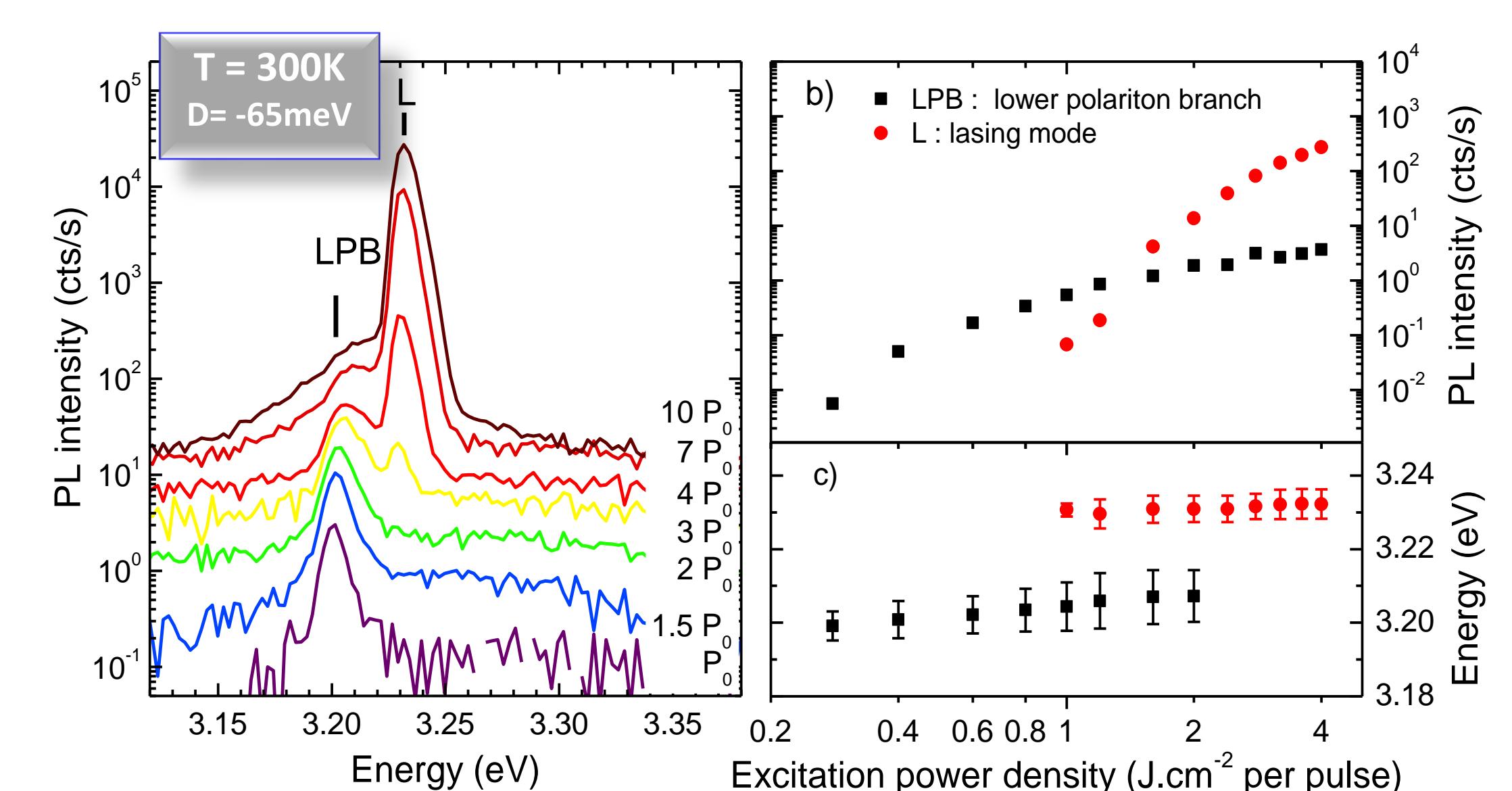
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Laser OPO, 3.78 eV, 3ns, rep. rate 10Hz / Spot diam. 50μm $P_0=0.4\text{ J/cm}^2$

T = 80 K : Evidence for exciton-mediated gain



T = 300 K : Still LASING !



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